Other Art

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Form PTO-1449 (modified) Atty. Docket No. Serial No. 2000.109000/DE0133 10/666,195 List of Patents and Publications for Applicant's Applicant Gerd Marxsen, Axel Preusse, Markus Nopper and Frank Mauersberger INFORMATION DISCLOSURE STATEMENT Filing Date: Group: (Use several sheets if necessary) 2811 September 19, 2003 U.S. Patent Documents Foreign Patent Documents See Page 1 See Page 1

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Atty. Docket No. 2000.109000/DE0133

Serial No. 10/666,195

Applicant

Gerd Marxsen, Axel Preusse, Markus Nopper and Frank Mauersberger

Filing Date: September 19, 2003 Group:

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